

INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)

Docket Number (Optional)

OKI.147

Application Number

09/497,499

Applicant(s)

K. Asakawa, et al.

Filing Date

02/04/2000

Group Art Unit

2814

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

WSL	1.	Sorab K. Ghandhi; "VLSI Fabrication Principles, Silicon and Gallium Arsenide" (Second Edition); Copyright 1994; pg. 528 and pg. 725; A Wiley-Interscience Publication, John Wiley & Sons, Inc.

EXAMINER

DATE CONSIDERED

4/20/02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.